

APPLICATION DATA SHEET

Electronic Version v14

Stylesheet Version v14.0

Title of Invention	METHOD FOR PATTERNING A SEMICONDUCTOR REGION
Application Type :	regular, utility
Attorney Docket Number :	FIS920040061US1
Correspondence address:	
Customer Number:	32074
	
Inventors Information:	
<u>Inventor 1:</u>	
Applicant Authority Type:	Inventor
Citizenship:	IN
Given Name:	Sadanand
Middle Name:	V.
Family Name:	Deshpande
Residence:	
City of Residence:	Fishkill
State of Residence:	NY
Country of Residence:	US
Address-1 of Mailing Address:	35 Beech Court
Address-2 of Mailing Address:	
City of Mailing Address:	Fishkill
State of Mailing Address:	NY
Postal Code of Mailing Address:	12524
Country of Mailing Address:	US
Phone:	
Fax:	
E-mail:	
<u>Inventor 2:</u>	
Applicant Authority Type:	Inventor
Citizenship:	IN
Given Name:	Rajiv
Middle Name:	M.

Family Name:	Ranade
Residence:	
City of Residence:	Fishkill
State of Residence:	NY
Country of Residence:	US
Address-1 of Mailing Address:	2 Noel Court
Address-2 of Mailing Address:	
City of Mailing Address:	Brewster
State of Mailing Address:	NY
Postal Code of Mailing Address:	10509
Country of Mailing Address:	US
Phone:	
Fax:	
E-mail:	

Inventor 3:

Applicant Authority Type:	Inventor
Citizenship:	US
Given Name:	George
Middle Name:	K.
Family Name:	Worth
Residence:	
City of Residence:	Gardiner
State of Residence:	NY
Country of Residence:	US
Address-1 of Mailing Address:	2880 Route 44-55
Address-2 of Mailing Address:	
City of Mailing Address:	Gardiner
State of Mailing Address:	NY
Postal Code of Mailing Address:	12525
Country of Mailing Address:	US
Phone:	
Fax:	
E-mail:	

Assignee 1:

Organization Name:	International Business Machines Corporation
Address-1 of Mailing Address:	New Orchard Road
Address-2 of Mailing Address:	
City of Mailing Address:	Armonk
State of Mailing Address:	NY

Postal Code of Mailing Address: 10504

Country of Mailing Address: US

Phone:

Fax:

E-mail: